

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Tatsuya SUZUKI et al.  
Appl. No.: NEW NON-PROVISIONAL Group:  
Filed: October 16, 2003 Examiner:  
For: METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE AND SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT  
(SUBMISSION CONCURRENT WITH THE  
FILING OF A NEW PATENT APPLICATION)

October 16, 2003

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, and in fulfillment of the duty of disclosure under 37 C.F.R. § 1.56, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications, or other information submitted for consideration by the Office are listed on PTO-1449, attached hereto.

II. COPIES

Submitted herewith is a legible copy of (i) each foreign patent; (ii) each publication or that portion which caused it to be listed; and (iii) all other information or that portion which caused it to be listed.

This application is a National Phase of a PCT application. Some or all of the documents listed on the PTO-1449 are not enclosed because they were cited in the International Search Report and copies should have been forwarded from the International Search Authority pursuant to the trilateral agreement between the USPTO, EPO and JPO. If copies are needed, please contact the undersigned.

III. CONCISE EXPLANATION OF THE RELEVANCE  
(check at least one box)

a.  DOCUMENTS IN THE ENGLISH LANGUAGE

The attached patents, publications, or other information in the English language do not require a statement of relevancy.

b.  DOCUMENTS NOT IN THE ENGLISH LANGUAGE

A concise explanation of the relevance of all patents, publications, or other information listed that is not in the English language is as follows:

References cited in the specification

c.  FOREIGN SEARCH REPORT OR ACTION

An English language version of the search report or action that indicates the degree of relevance found by the foreign office is attached, thereby satisfying the requirement for a concise explanation. See MPEP 609(A)(3).

d.  OTHER

The following additional information is provided for the Examiner's consideration.

FEES

This Information Disclosure Statement is being filed concurrently with the filing of a new patent application; therefore, no fee is required.

If the Examiner has any questions concerning this IDS, he/she is requested to contact the undersigned.

Respectfully submitted,

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TWP/maf

Enclosures:  Form PTO-1449(s)  
 Documents  
 Foreign Search Report  
 Other: \_\_\_\_\_

10-1445

**INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION**

(Use several sheets if necessary)

Attorney Docket No.:  
**8070-1003**

Application No.:

Applicant:  
**Tatsuya SUZUKI et al.**

Filing Date:  
October 16, 2003

**Group Art Unit:**

## U.S. PATENT DOCUMENTS

**FOREIGN PATENT DOCUMENTS**

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)  
"Clean UU SI Technology," 1995, BAIFUKAN, Tokyo, Japan

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)  
OHMI, Tadahiro. "Ultra Clean ULSI Technology," 1995, BAIKUAN, Tokyo, Japan

EXAMINER:

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience

DATE: 01/01/2024

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\* Abstract provided for the Examiner's convenience

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Y&T October 16, 2003